

AC IMPEDANCE SPECTROSCOPY OF Al/a-SiC/c-Si(p)/Al HETEROSTRUCTURE UNDER ILLUMINATION

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The amorphous silicon carbide/crystalline silicon heterojunction was prepared and analyzed. The current-voltage ($I - V$) measurements showed the barrier properties of prepared sample. Biased impedance spectra of Al/a-SiC/c-Si(p)/Al heterojunction under the standard illumination are reported and analyzed. AC measurements in the illuminated conditions were processed in order to identify electronic behavior using equivalent AC circuit which was suggested and obtained by fitting the measured impedance data. A phenomenon of negative capacitance/resistance in certain frequency range has been observed.

Keywords: PECVD, heterojunction, silicon carbide, equivalent AC circuit, complex impedance

1 INTRODUCTION

Slightly doped amorphous silicon carbide layers a-SiC (alternatively modified with other chemical elements, *eg* nitrogen N in our case) which form heterojunction with crystalline silicon are relevant substitute for amorphous silicon (a-Si:H). The conversion efficiency up to 22% of heterojunction solar cell (a-Si:H/c-Si) was reported and any further substantially increase is not expected [1]. In the case of amorphous silicon the problem lies in increased recombination when a thicker layer of a-Si:H is used. Short circuit current I_{sc} of a-Si:H/c-Si solar cell structures is expected to increase when a-Si:H is substituted by a larger band gap material.

The width of the band gap can be controlled in a wide range in the case when carbon is added to the amorphous a-Si:H (resulting in hydrogenated silicon carbide alloy at greater amount of carbon). Increased carbon concentration (x) in $a\text{-Si}_x\text{C}_{1-x} : \text{H}_y$ leads to better light absorption efficiency of heterojunction a-SiC:H/c-Si solar cells [2]. Deterioration of electronic properties (mainly electron mobility decrease) due to various kinds of amorphous network structural disorder is a negative accompanying phenomenon related to increasing concentration of carbon. In limit case, when the carbon concentration is closed to 100%, it leads to creation of amorphous carbon layers or diamond-like carbon films, respectively. Thin films of amorphous SiC or amorphous C as an emitter layer for heterojunction solar cells applications has been the subject of several studies [3, 4] but commercial outputs in the form of heterojunction solar cell devices still lack. Optimization of technology (deposition parameters, precursor gases, doping) has been the subject of research [5–8] and is still a major challenge for further research.

Other applications, in addition to the use of a-SiC as an emitter layer of mentioned heterostructures, are possible and have been investigated. Thin a-SiC can be used as diffusion barrier, passivation layer and a barrier layer, *eg* within the structure of amorphous silicon solar cells. This alloys shows to be promising also as both, etch stop [9, 10] and hard mask layer [11] to assist nanoelectronic patterning, and as low dielectric constant (known as low-k) interfacial dielectric material [12], diffusion barrier [13–15], and pore sealants [16]. Controllability of the band gap allows a wide range of applications especially in microelectronics, including thin dielectric layers and semiconductor applications. Optoelectronic applications as another important area include the use of a-SiC photodiodes in optical communications [17], optical/image sensors [18] and LED's applications [19]. Another field of applications a-SiC has found in micro electromechanical systems [20].

The DC and AC measurements under illumination were performed in order to detect the electronic properties and PV parameters of chosen prepared sample which was prepared in the context of previous research of optimization the technology [21].

2 EXPERIMENTAL

The plasma CVD reactor with parallel plate electrodes was used for samples preparation. A p-type silicon wafer with resistivity 6–10 Ωcm and (100) orientation was used as the substrate for the growth of SiC layers doped by nitrogen (SiC(N)). Technological conditions for sample preparation were: gas mixture (SiH_4 -5 sccm, CH_4 -30 sccm, NH_3 -3 sccm, H_2 -100 sccm, Ar-10 sccm). The temperature of substrate during the deposition was

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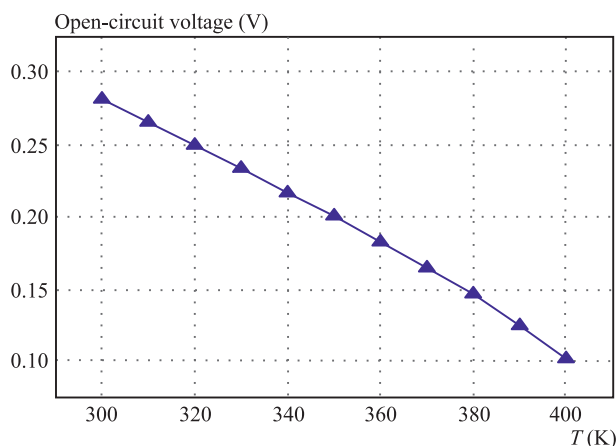


Fig. 1. Open circuit voltage temperature dependences at irradiation intensity 945 Wm^{-2} of prepared sample

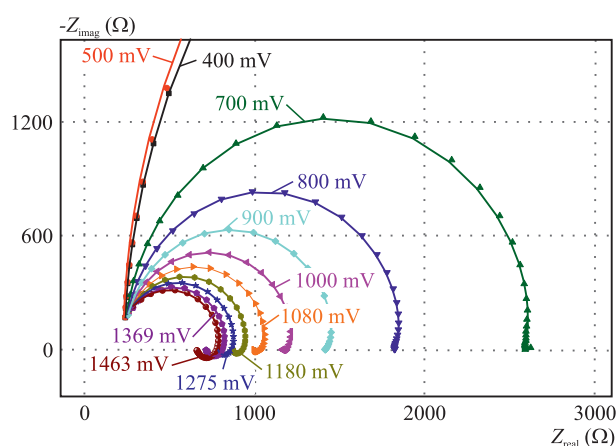


Fig. 2. Measured (symbol) and fitted (line) impedance spectra of Al/a-SiC/c-Si(p)/Al sample under illumination at room temperature at different forward bias

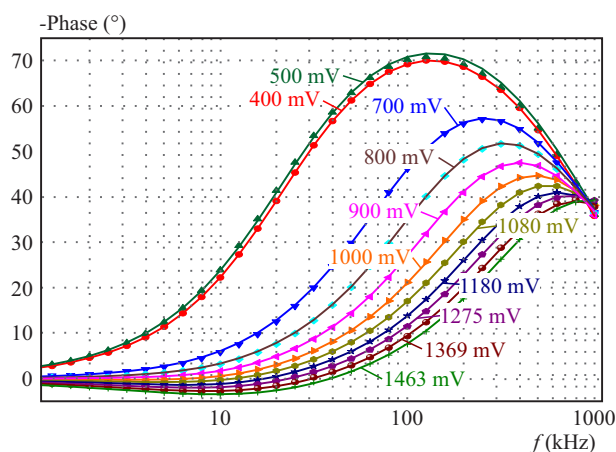


Fig. 3. Measured (symbol) and fitted (line) frequency dependence of impedance phase at room temperature in the dark of sample T3

300°C , RF power 100 W and pressure 35 Pa in the chamber. Introduction of the hydrogen to the gas mixture results in the production of samples which can be denoted as a-SiC(N):H films (for simplification further denoted here only as an a-SiC). The circular electrodes of Al

(120 nm thick) were formed on the side with SiC film on each sample. The ohmic contact on the opposite side of samples was created — the whole area Al, app. 250 nm thick. Other technological parameters can be found in [21]. The samples formed on Si were annealed in a furnace with forming gas atmosphere (90% N, 10% H) for 30 min (heated $100^\circ\text{C}/\text{min}$ from room temperature) at temperature 430°C and pressure 1 kPa.

DC measurements were performed using Keithley 237 at the temperatures within the interval from 300 K to 400 K and controlled by program DCATS. AC impedance spectroscopy measurement and characterization was performed by SOLARTRON Analytical Module. The measurements were done under illumination within the frequency range from 1 Hz to 1 MHz. Solar simulator ORIEL class AAA was used for the measurement of PV parameters of illuminated sample.

3 RESULTS AND DISCUSSION

The results obtained from dark I-V measurements (presented in [21]) indicate the barrier properties of prepared structure and presence of photovoltaic effect was observed under illumination. Basic PV parameters (V_{oc} and FF) were determined as $V_{oc} = 0.292$, $FF = 0.20$. The efficiencies were not calculated while with regard to character of prepared samples (top point contacts) we cannot exactly define the geometry and obtain exact “solar cell” area of the structure. The shape of $I - V$ curves is strongly influenced by series resistance. High series resistance results in low FF . Temperature dependence of open-circuit voltage were also measured under illumination and the results are shown in Fig. 1. The dependence of open-circuit voltage on the temperature shows linear behavior. Finally that means that the conversion efficiency decreases when the temperature increases as it is generally common.

AC impedance spectroscopy characterization was performed by SOLARTRON Analytical Module in order to detect the frequency response of Al-a-SiC/c-Si(p)/Al heterojunctions and identify equivalent circuit of Al-a-SiC/c-Si(p)/Al samples. The measurements were performed at room temperature and on illuminated samples in the frequency range from 1 Hz to 1 MHz and also at different forward bias voltages. Measured impedance spectra or Nyquist characteristics are shown in Fig. 2. At frequencies up to 50 kHz and DC biases higher than 1000 mV the frequency response of complex impedance related to standard models of capacitive samples is not more valid. The positive values of Z_{imag} were obtained at low frequencies, usually ascribed to inductive character of the impedance.

For more detailed analyses we introduce the dependence of phase angle on frequency shown in Fig. 3. Given the nature of the studied impedance (thin a-SiC layer between two electrodes) the capacitance character of samples and negative phase on the whole frequency range

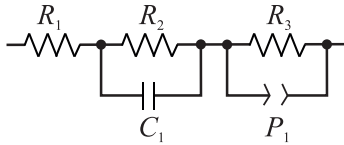


Fig. 4. Proposed equivalent circuit of the heterostructure Al-a-SiC/c-Si(p)/Al

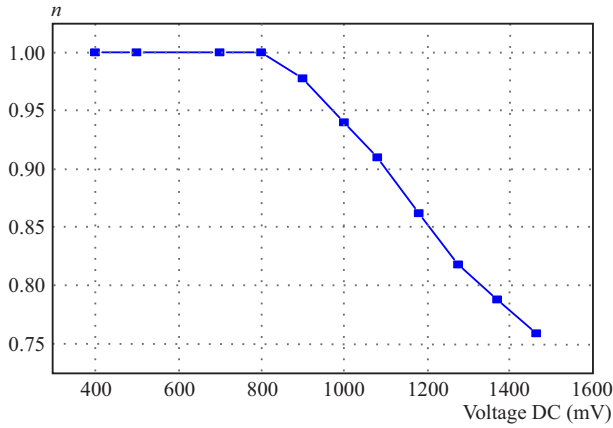


Fig. 5. Power law factor n as a function of applied DC bias

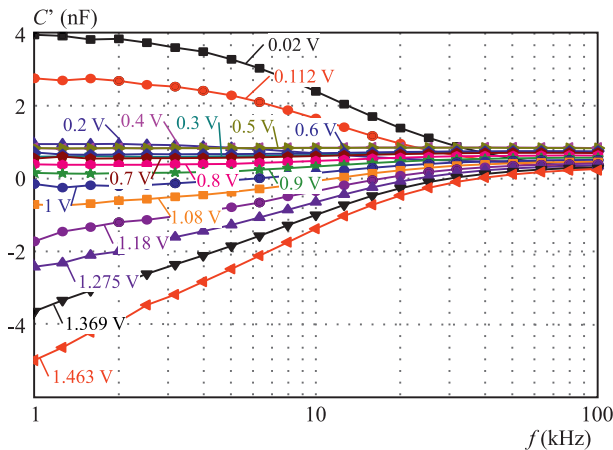


Fig. 6. Real part of AC Capacitance (C') as a function of forward bias voltage at room temperature under illumination

would be expected. As shown in Fig. 3, the positive phase of the complex impedance can be observed. It is at higher bias voltages, app. 1000 mV, and at frequencies lower than approximately mentioned 50 kHz. Usually such frequency dependence is attributed to the conventional inductance of the system (generally ascribed to the electric conductive interconnections). In our case such reasoning would be incorrect for two main reasons. The inductance makes sense when strong magnetic field is applied, which is not the case here. And also, for the case that classical inductance $I Z I = \omega L$ and its influence could be observed, however, it is so at higher frequencies, often about 1 MHz. Therefore, the anomalous behavior in Fig. 3 is not the result of parasitic inductance. Similar explanation can be found in [18].

It is evident that the simple equivalent circuit with one parallel RC combination must be modified and the

contribution of the interfacial states has to be taken into account. They offer an additional conductive path related to the recombination in the junction. According to the theory presented in [23] each energy level E_i in the band gap introduces one CR time constant. We have searched for the best fitting circuit with regard to the shape of frequency dependence of impedance spectra (Fig. 2) and their phase (Fig. 3). Usually the transport processes related to the junction of heterostructures are represented as connection of R and C elements. In our case we introduce constant phase element P except of capacitor. The measured network reflects the contribution of the junction C_1 parallel to $G_2 = 1/R_2$, the interface states P_1 parallel to $G_3 = 1/R_3$ and series resistance R_1 . We have decided to use series connection of parallel RC elements while in the case when resistor R_3 is of small values, as it is in the case of lower voltages and shown in Fig. 4, constant phase element P_1 is actually shunted by parallel resistor R_3 .

Constant phase element (CPE) in AC equivalent circuit represents different inhomogeneities such as blocking effects (interfacial states, porosities, etc). The electrical impedance of CPE is expressed as

$$Z_{CPE} = 1/C_{PE}(i\omega)^n. \quad (1)$$

CPE is in fact classical capacitors in the case when $n = 1$. Variation of exponent n on the applied DC voltage is shown in Fig. 5. As can be seen in Fig. 5, CPE behaves like a classical capacitor only when low levels of DC bias are applied.

The measured real part of capacitance at low bias voltages (V) is positive and decreases with increasing bias as can be seen in Fig. 6.

For higher forward bias voltages (V), the real part of capacitance turns to negative values. This effect was also observed and presented either on organic [24] or inorganic layered structures [25]. The phenomenon can be attributed to the carrier capture and emission from the interface states. The negative capacitance can be attributed to the existence of defect states at the interfaces between crystalline semiconductor and amorphous carbide layer [26].

The parallel resistances R_2 and R_3 of equivalent AC circuit were estimated under illumination at different bias conditions. The resistances R_2 and R_3 are dependent on the applied voltage. Decrease of the resistance in the case of R_2 and R_3 with increasing forward bias is depicted in Fig. 7. Negative resistance was detected in the case of R_3 at higher biases what is consistent with the ideas mentioned above. Series resistance R_1 is quite high and only a little influenced by voltage bias.

4 CONCLUSIONS

The heterojunction structure Al/a-SiC/c-Si(p)/Al prepared by PECVD method was studied by electrical analyses. The prepared samples show photovoltaic behavior

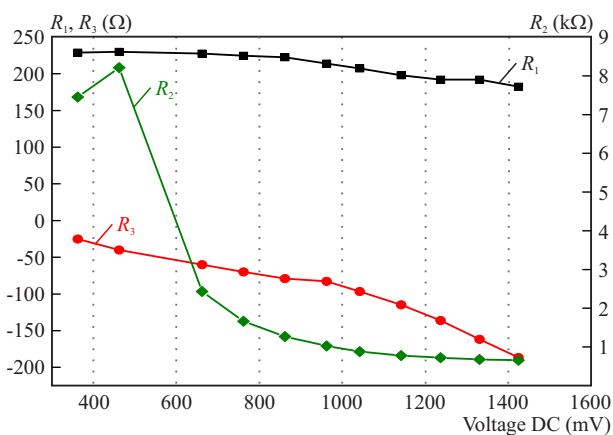


Fig. 7. Equivalent circuit resistances as a function of applied bias under illumination at room temperature (the connecting lines are not a functional equivalent)

and basic PV parameters were determined from current-voltage (I-V) characteristics under light. The impedance spectroscopy (the measurements under illumination) was applied to study the electric properties and equivalent AC circuit was estimated. Anomalous behaviour of the complex impedance character at lower frequencies and higher forward bias voltages was detected and discussed. The negative capacitance indicates the existence of defect states at the interface between crystalline semiconductor and amorphous layer. The impedance spectroscopy shows to be convenient powerful method to reveal such interesting behaviour and improve the picture about the transport processes in studied structures.

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